

Please type a plus sign (+) inside this box → [+]

PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE


Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	09/352,362
				Filing Date	July 13, 1999
				First Named Inventor	Shunpei YAMAZAKI et al.
				Group Art Unit	2815
				Examiner Name	J. Diaz
Sheet	1	of	1	Attorney Docket Number	0756-1996

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		6,071,796	A	Voutsas	06/06/2000	
		5,648,276	A	Hara et al.	07/15/1997	
		5,481,121		Zhang et al.	01/02/1996	
		5,514,879		Yamazaki	05/07/1996	
		5,578,520		Zhang et al.	11/26/1996	
		5,604,360		Zhang et al.	02/18/1997	
		5,605,846		Ohtani et al.	02/25/1997	
		5,620,910		Termoto	04/15/1997	
		5,795,795		Kousai et al.	08/18/1998	
		5,693,541		Yamazaki et al.	12/02/1997	
		5,808,321		Mitanaga et al.	09/15/1998	
		6,077,731		Yamazaki et al.	06/20/2000	

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office ³	Number ⁴	Kind Code ⁵ (if known)			

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature		Date Considered	1/24/02
-----------------------	---	--------------------	---------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-1996

Serial No. 09/352,362

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: July 13, 1999

Group Art Unit: 2815

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
P	08-078329	03/22/1996	JP			Eng Abst

OTHER DOCUMENT (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
P	Aya et al., "Improvement of SPC Poly-Si Film Using the ELA Method", pp. 167-170, 1997, AM-LCD 97, Digest of Technical Papers
W	Abe et al., "High Performance Poly-Crystalline Silicon TFT's Fabricated Using the SPC and ELA Methods", pp. 85-88, 1998, AM-LCD 98, Digest of Technical Papers
W	Specification & Drawings of US Patent Application Serial No. 09/352,373
W	Specification & Drawings of US Patent Application Serial No. 09/352,194
P	Specification & Drawings of US Patent Application Serial No. 09/352,198
P	Specification & Drawings of US Patent Application Serial No. 09/894,125
P	Specification & Drawings of US Patent Application Serial No. 09/369,158
W	Specification & Drawings of US Patent Application Serial No. 09/908,727
P	Dorin et al., "Chemistry The Study of Matter", pp. 532, 1992, Prentice Hall

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

03/19/2002

RECEIVED
MAR 28 2002
TECHNOLOGY CENTER 2800